



Radiation Source

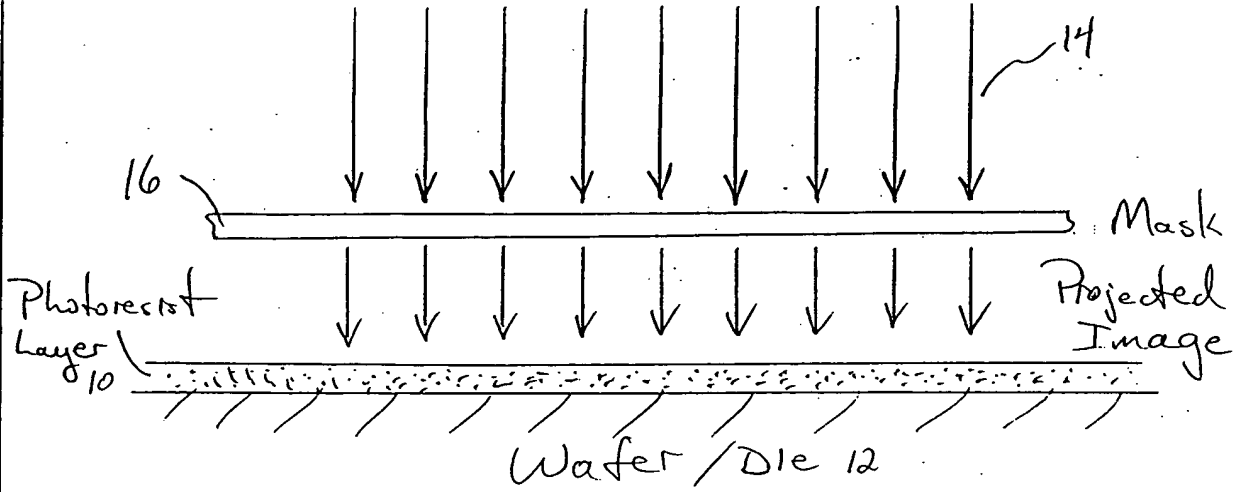


Fig. 1

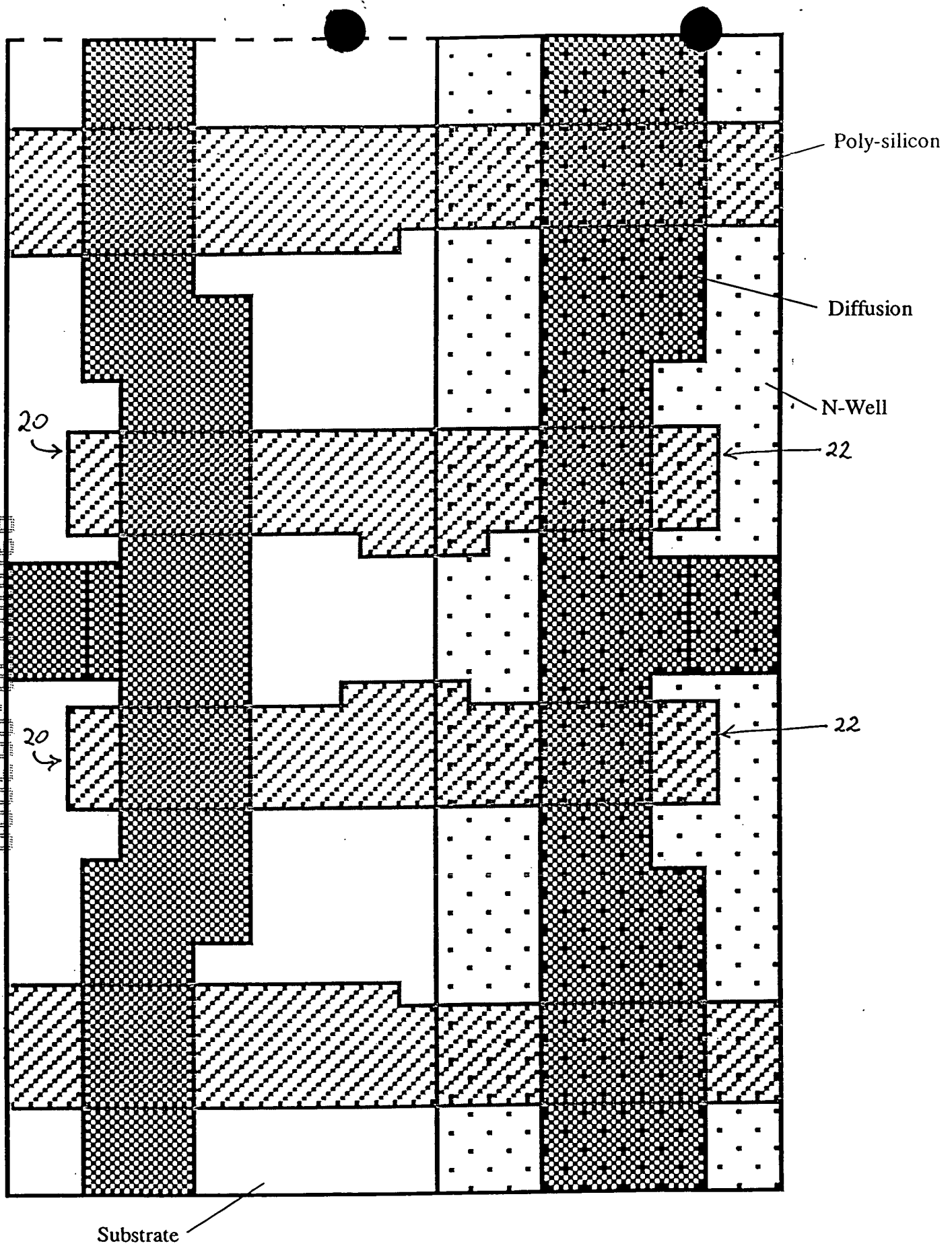


Fig. 2A

poly-silicon

diffusion

substrate

24

28

24

28

30

30

26

28

28

26

Fig. 2B

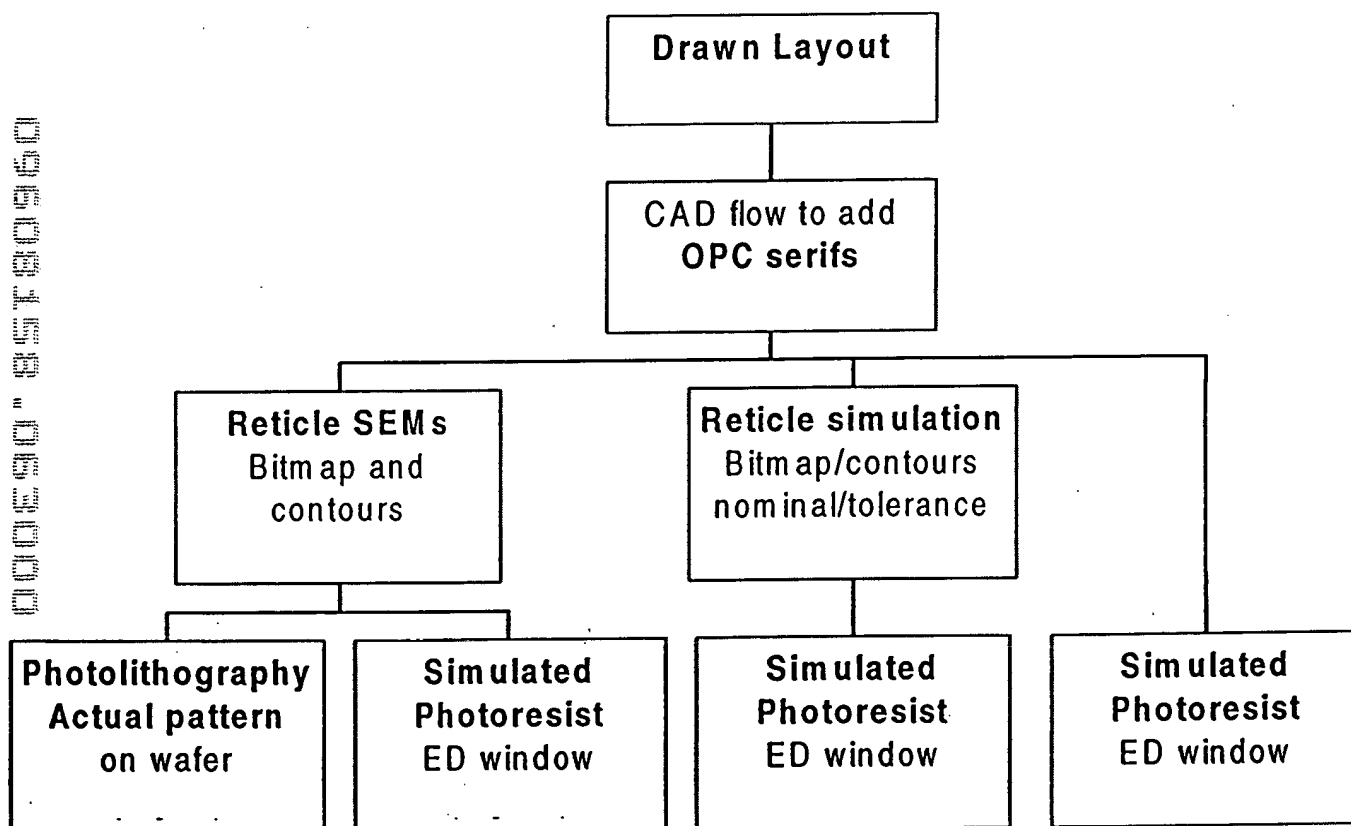
[illegible]

Fig. 3

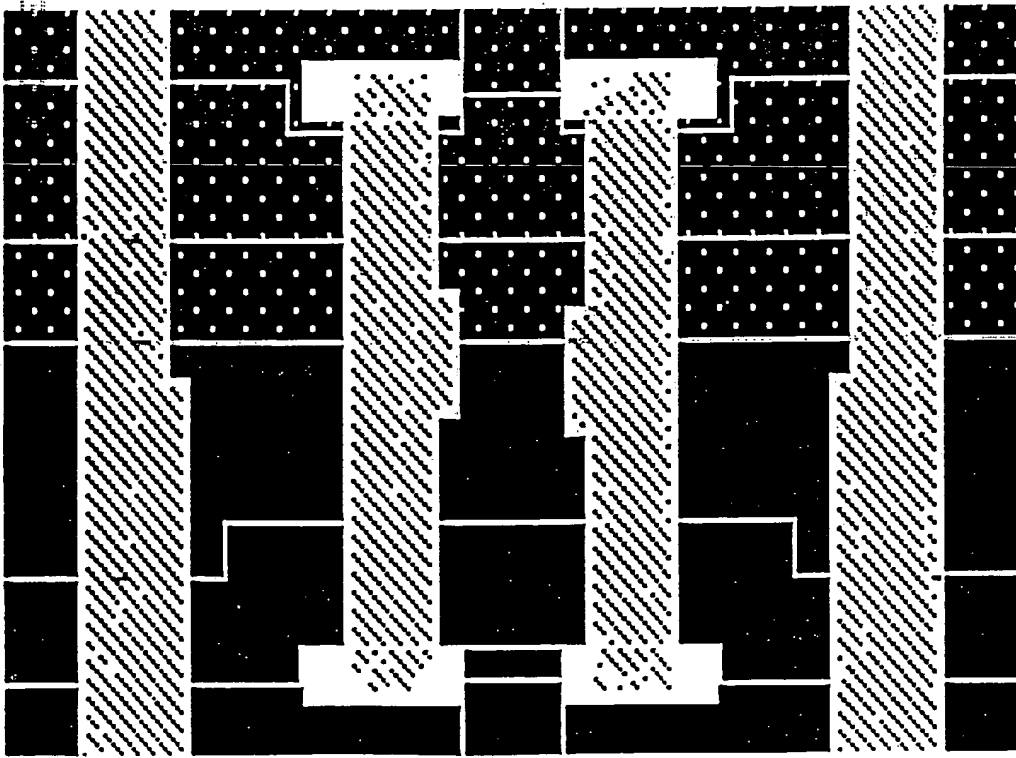


Fig. 4A

90° 85° 90°

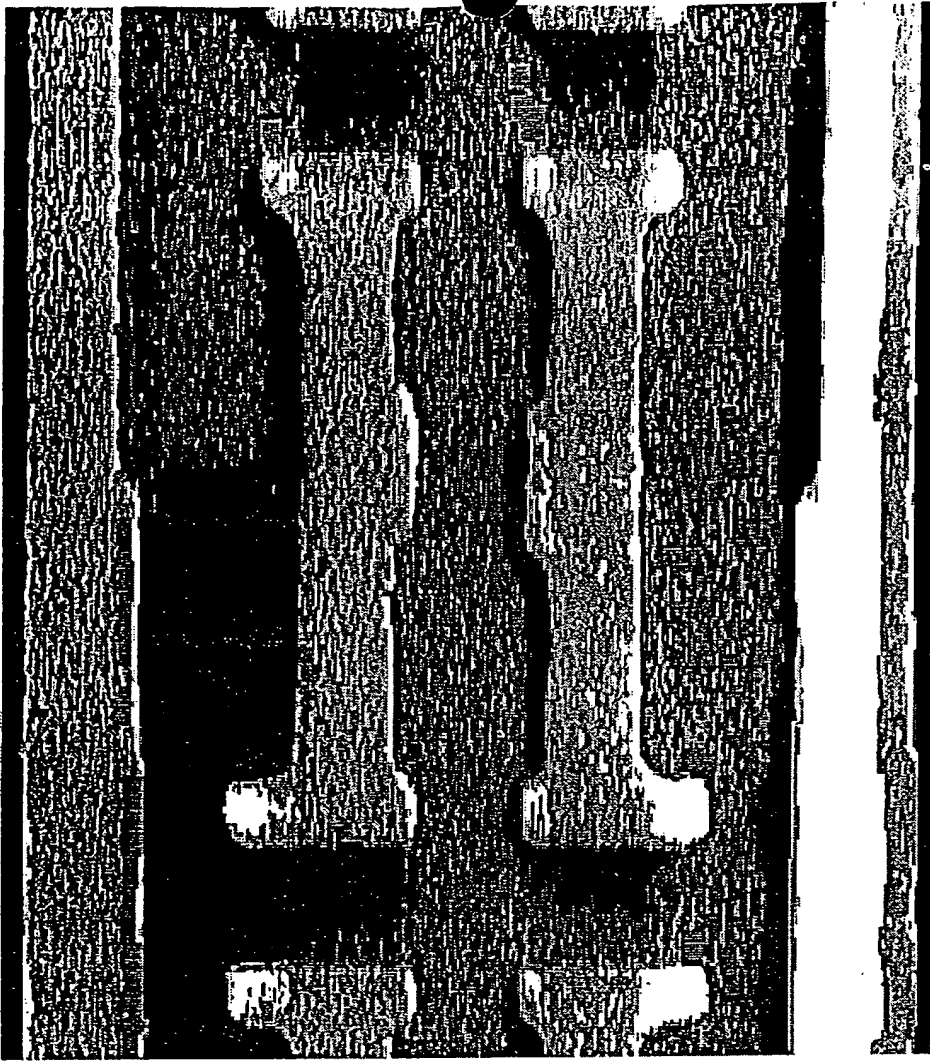


Fig. 4B

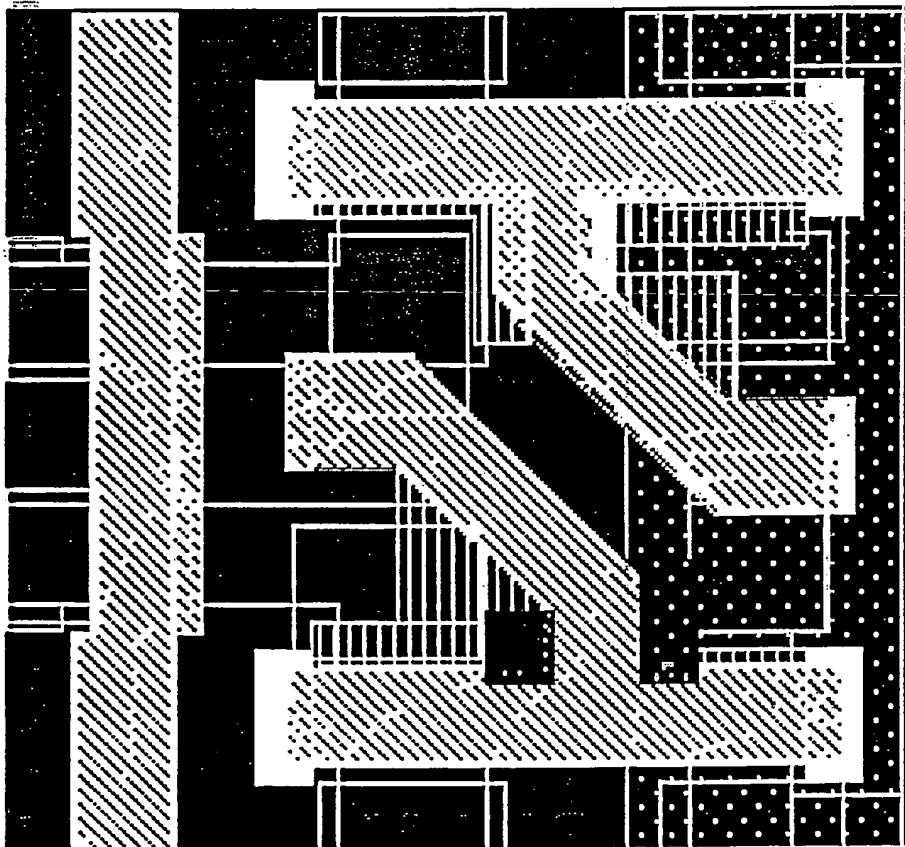


Fig. 5A

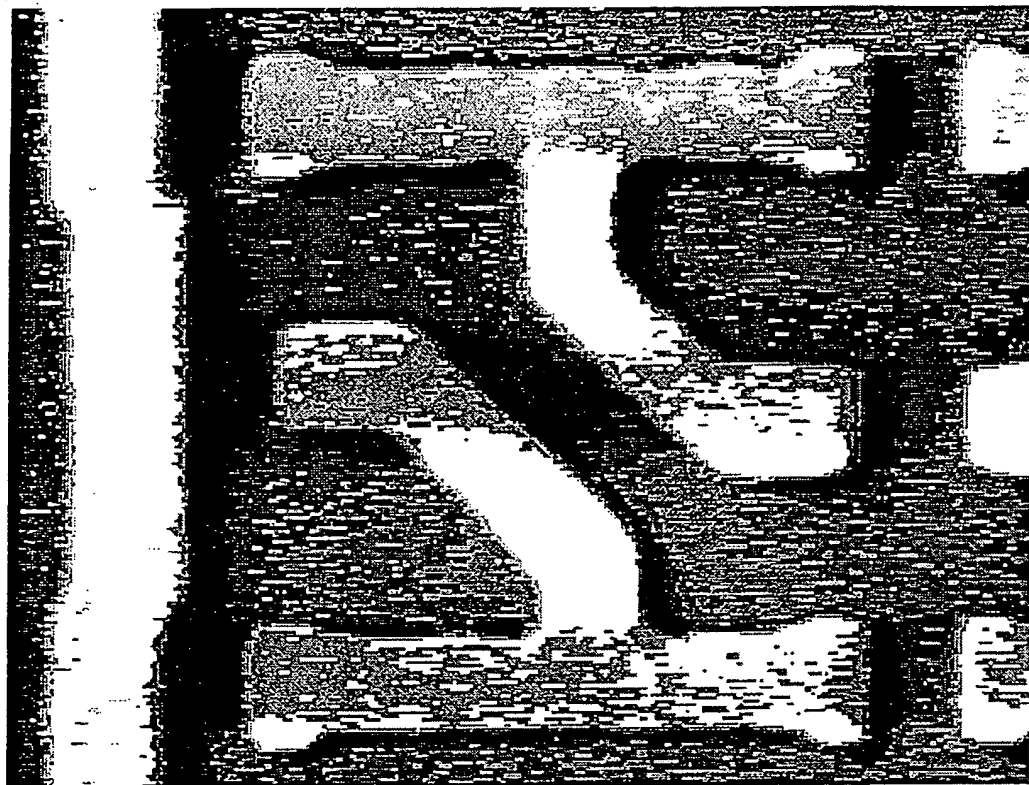


Fig. 5B

Fig. 6A

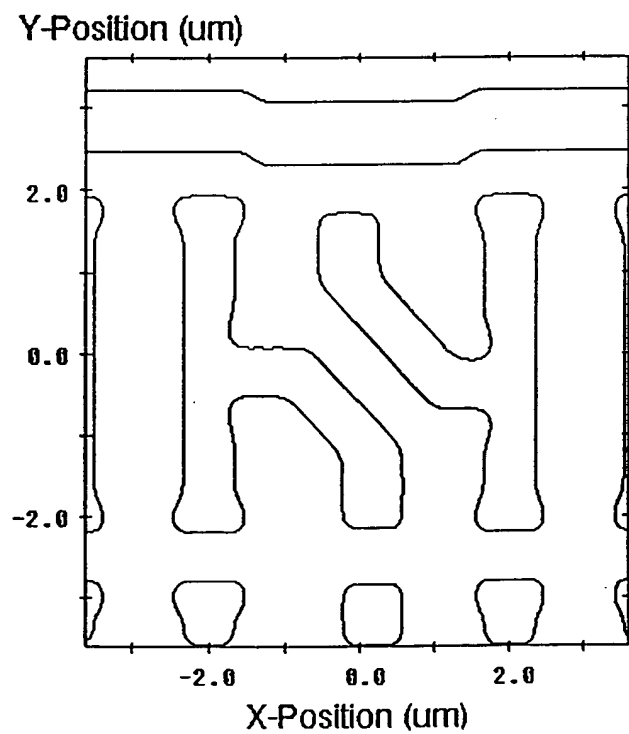


Fig 6B

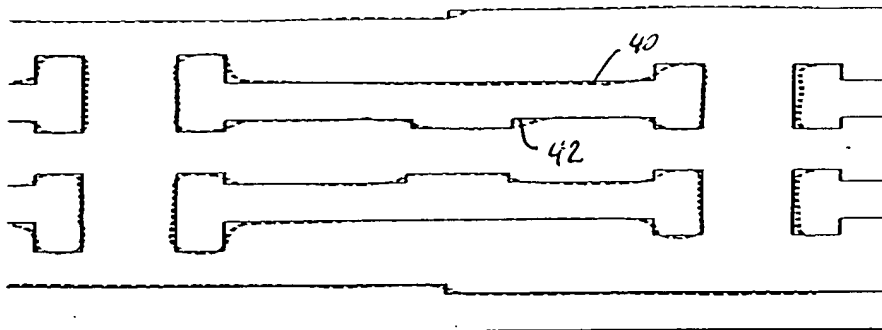


Fig. 7A

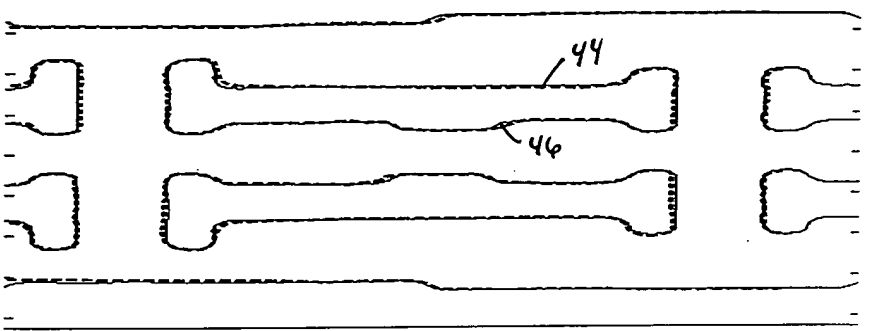


Fig 7B

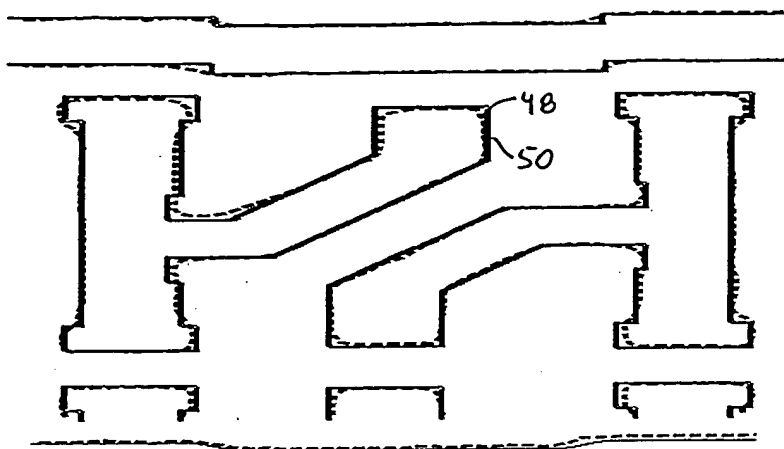


Fig 7C

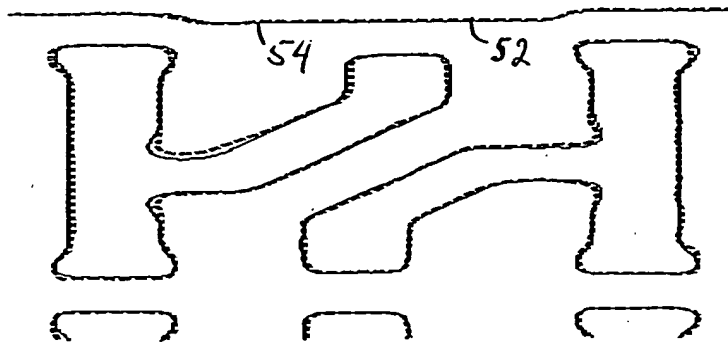


Fig 7D



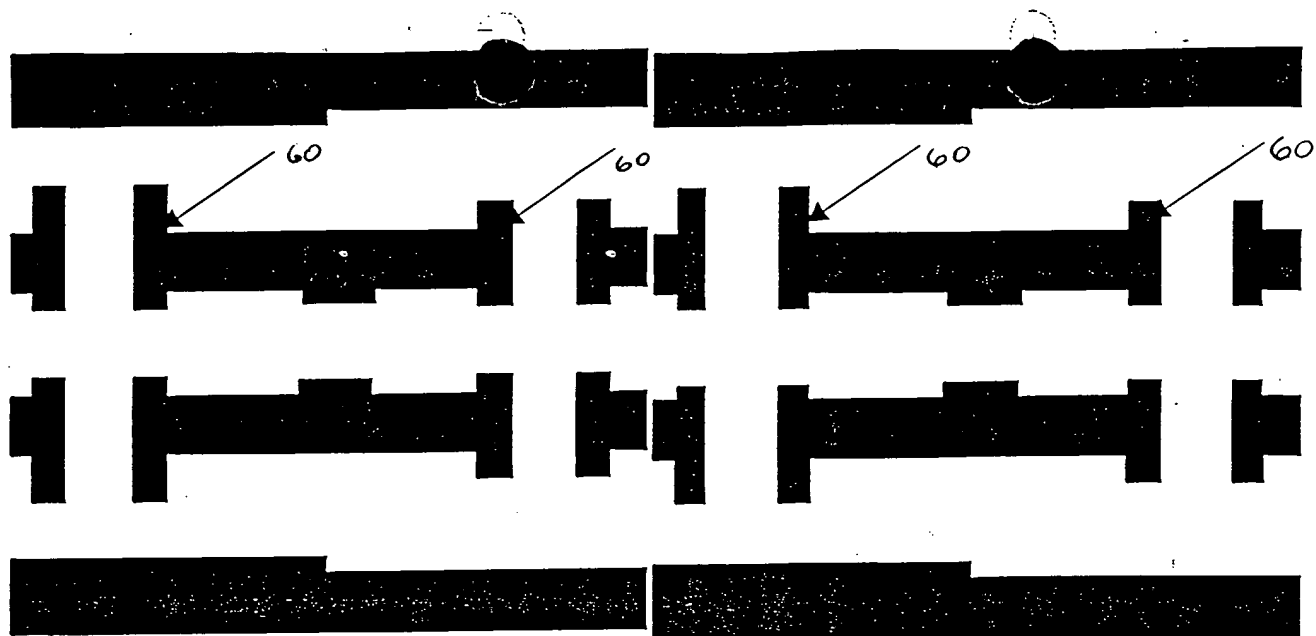


Fig. 8A

Fig 8B

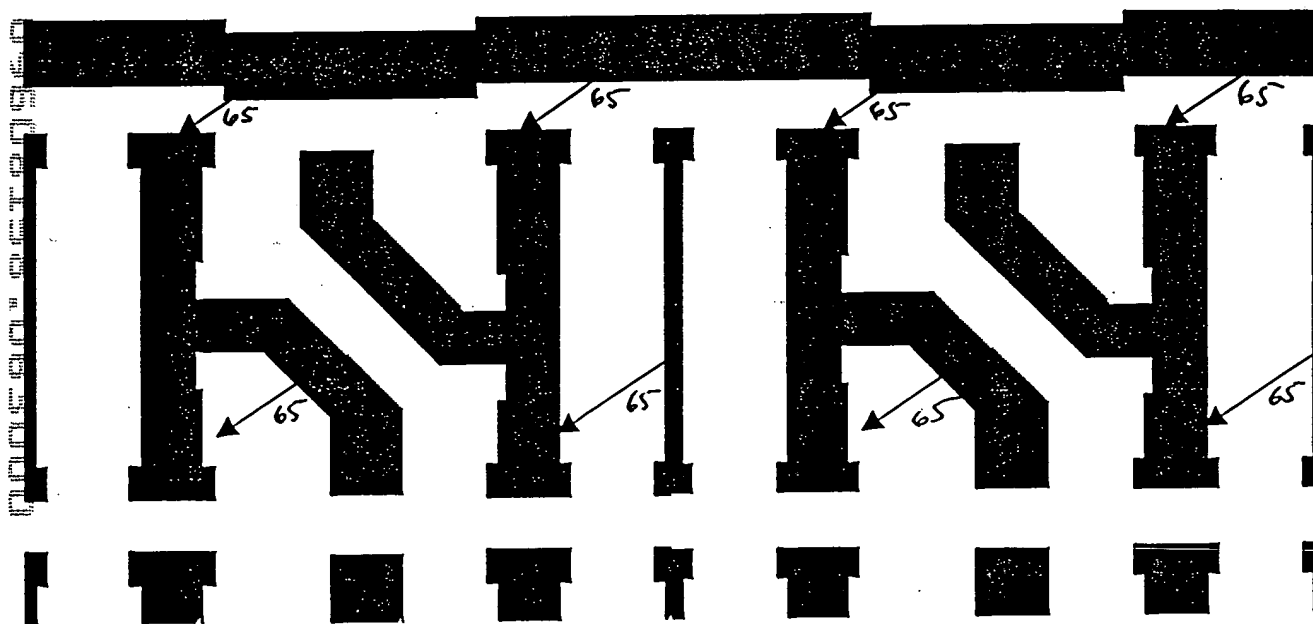


Fig 8C

Fig 8D

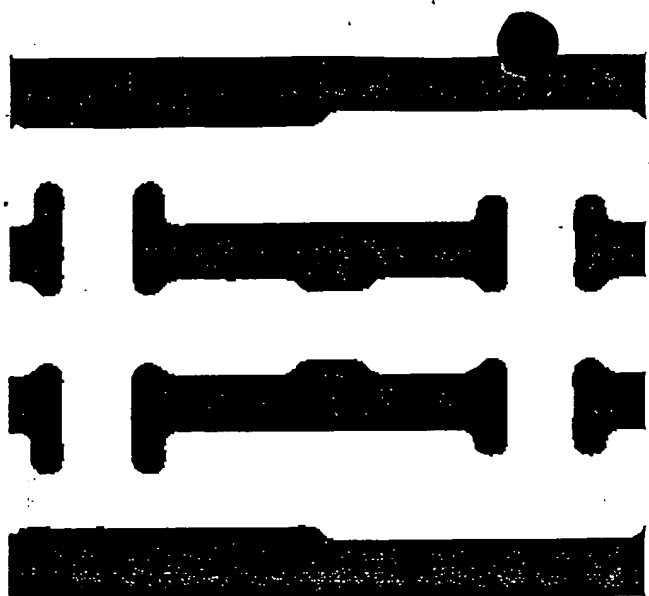


Fig. 9A

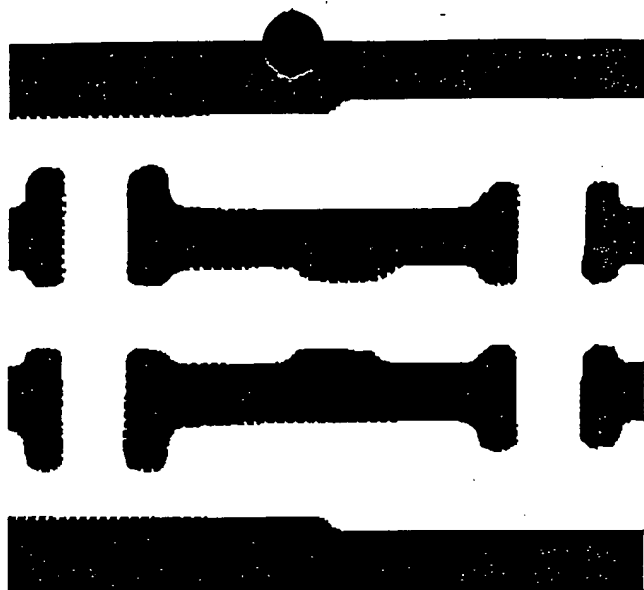


Fig 9B

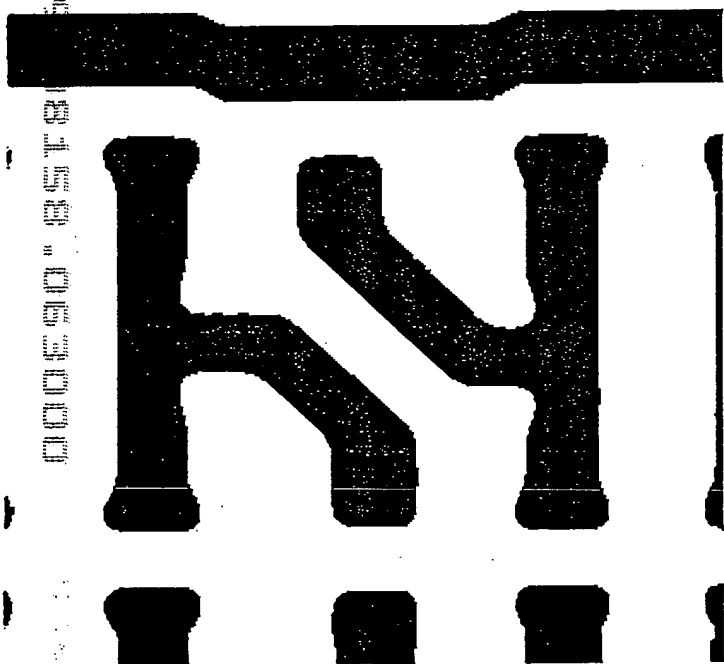


Fig 9C



Fig 9D

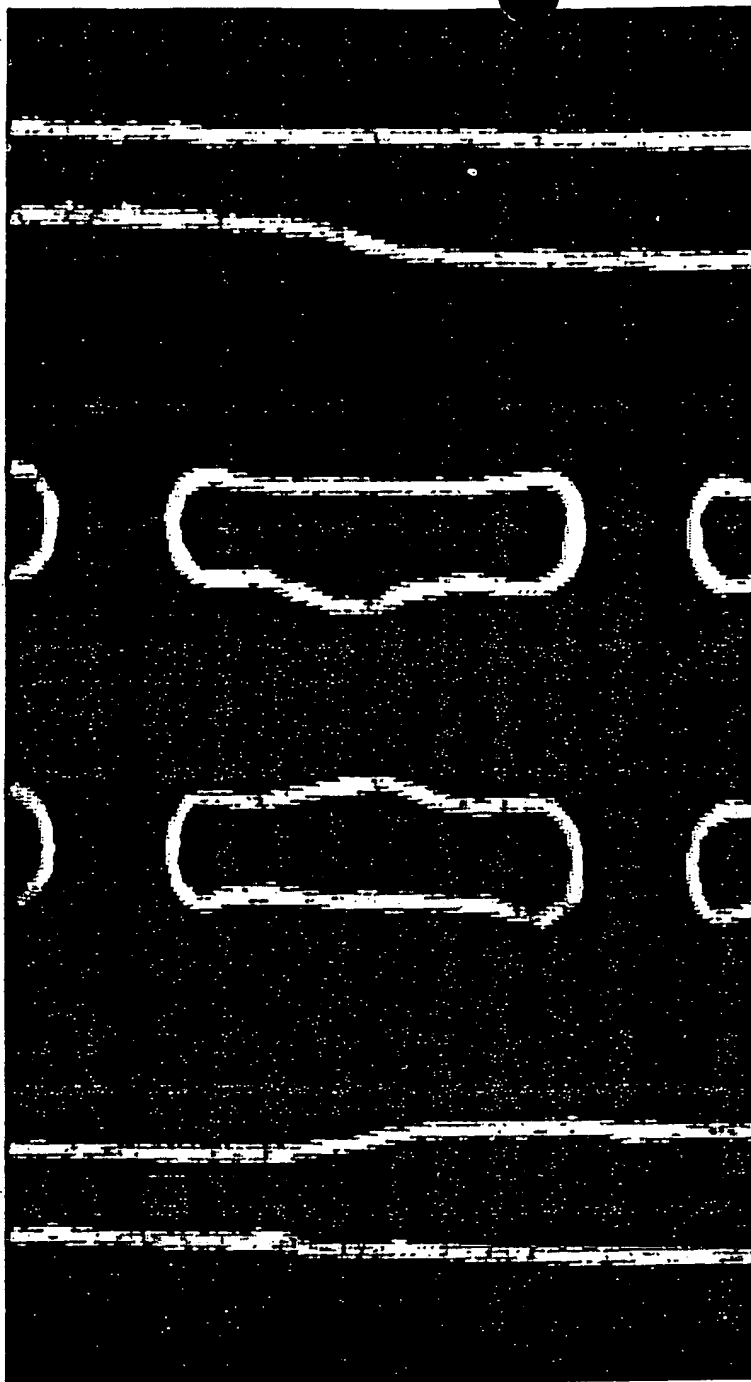


Fig 10A

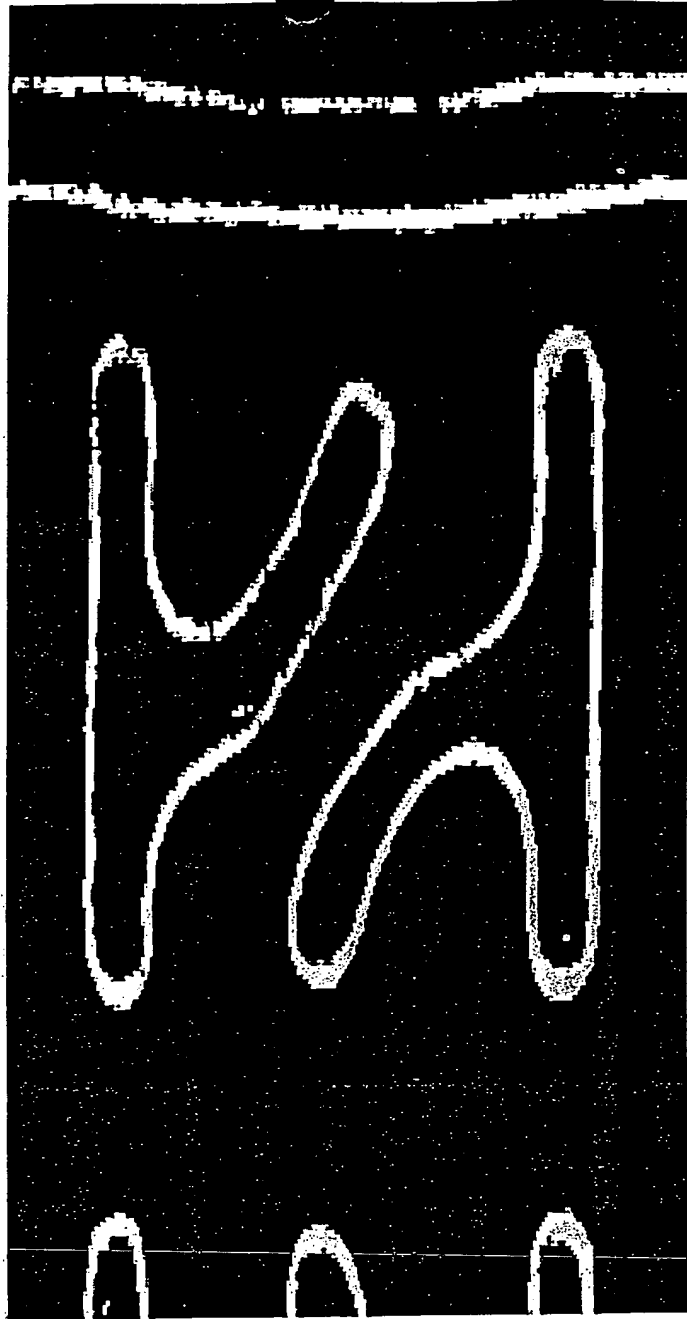


Fig 10B

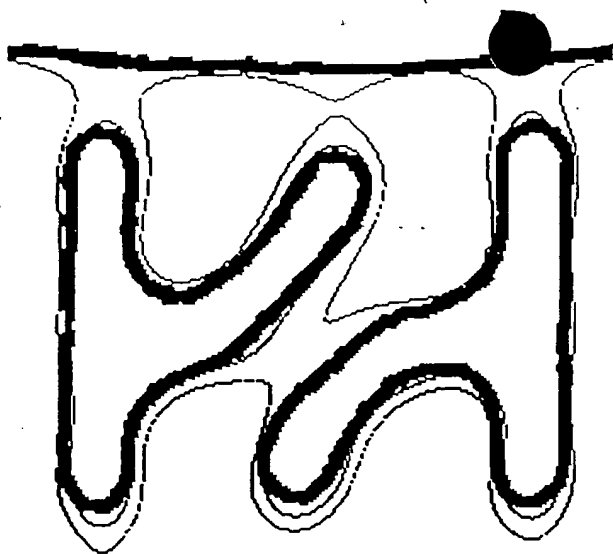


Fig 11A

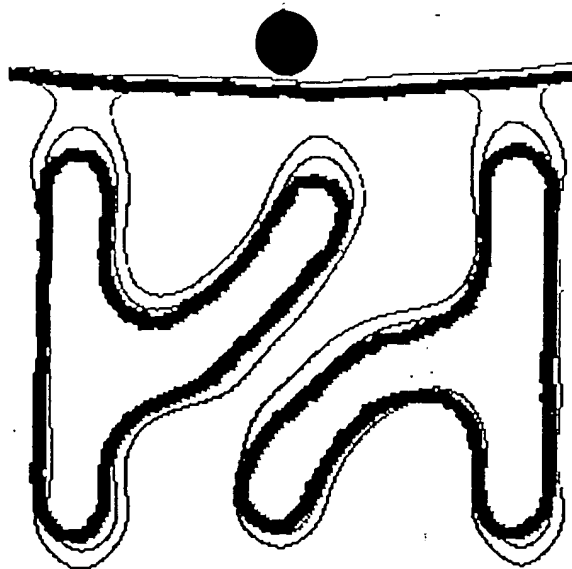


Fig 11B

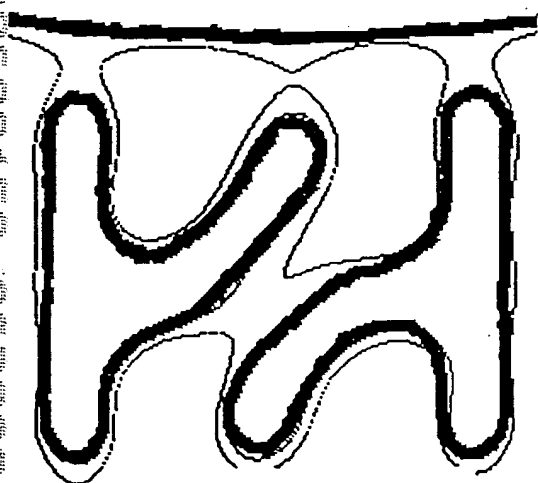


Fig 11C

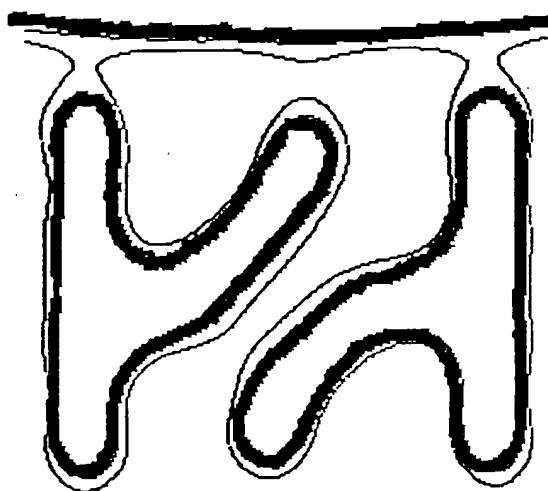


Fig 11D

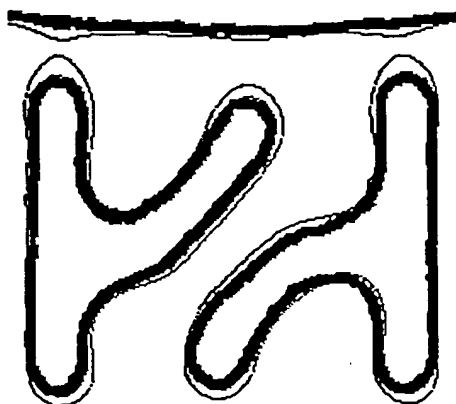


Fig 11E

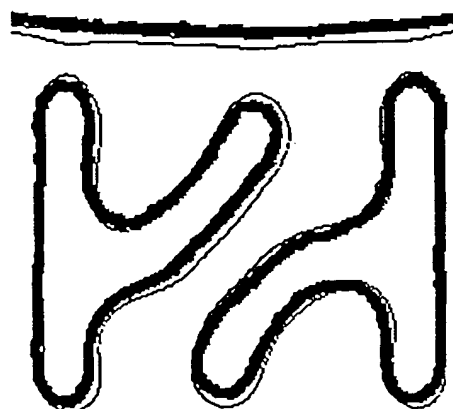


Fig 11F

000E90" 85T80950

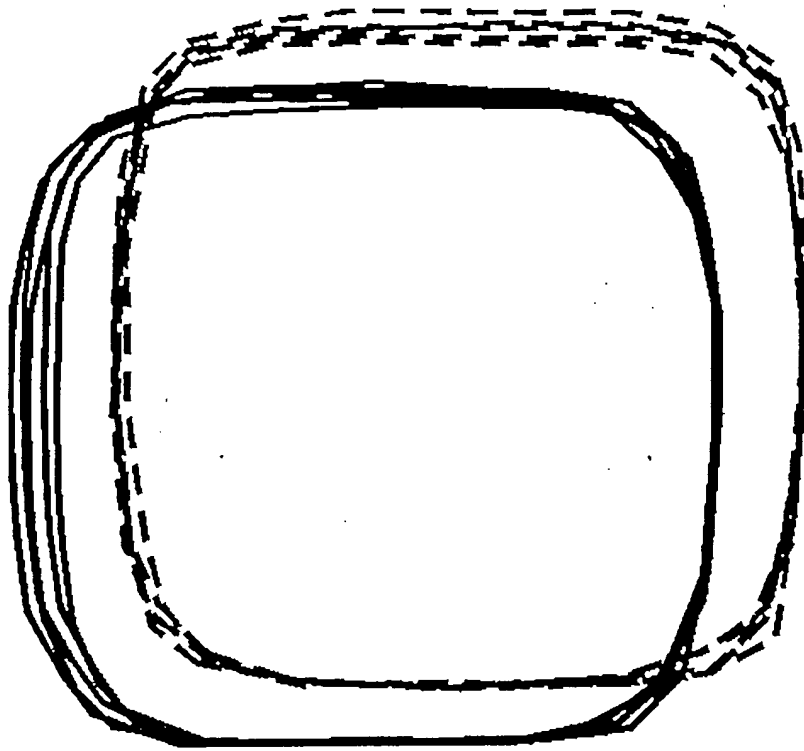


Fig 12A

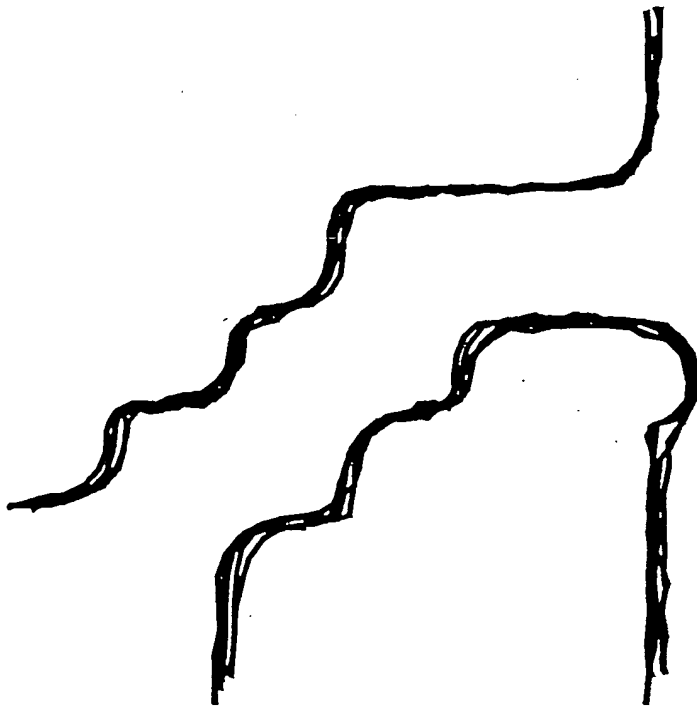


Fig 12B

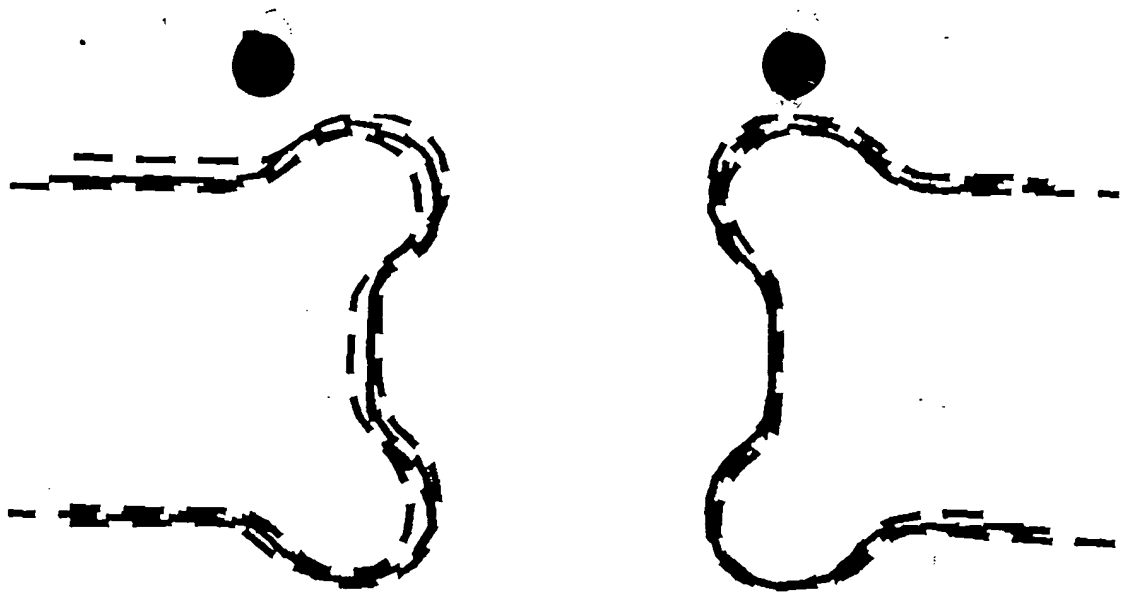


Fig 13A

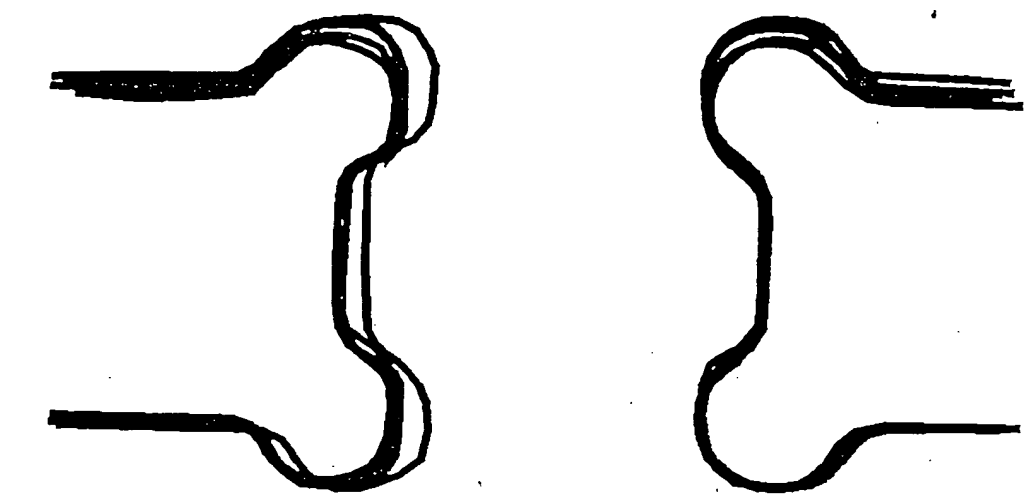


Fig 13B

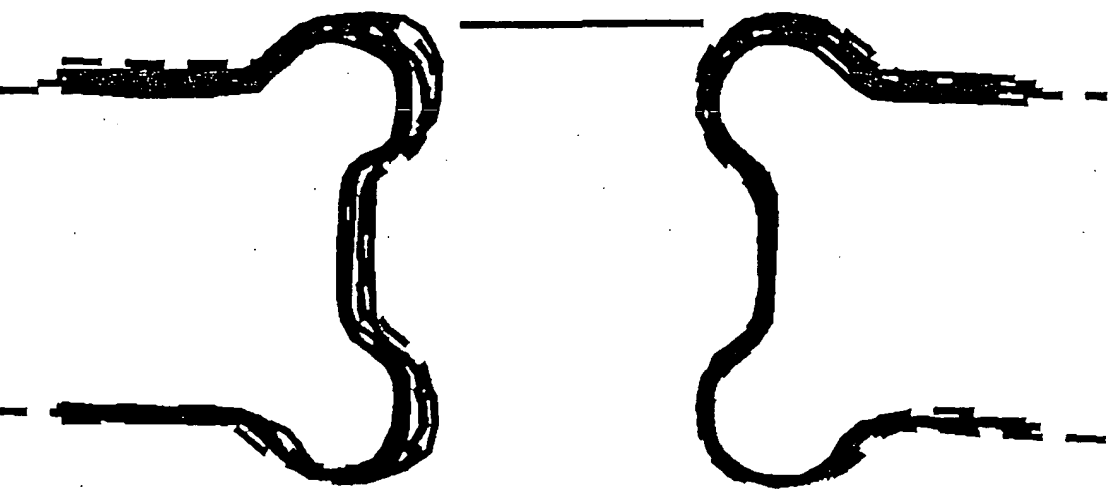


Fig 13C